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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yoo, Woo Sik
Assignee: WaferMasters, Inc.
Title: Method for H2 Recycling In Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
Examiner: Olivia T. Luk Group Art Unit: 2812
Docket No.: M-8608US

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Irvine, California
August 21, 2002

BOX AMENDMENT
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

PETITION FOR EXTENSION OF TIME

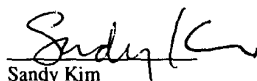
Dear Sir:

Applicant(s) respectfully petition(s) for a 1-month extension of time within which to respond to the Notice of Restriction Requirement dated June 27, 2002, such extension allowing the undersigned until August 27, 2002 to respond.

Please charge the fee of \$65.00 to the undersigned's Deposit Account No. 50-2257.


Please charge any additional fees or credit overpayment to the above-deposit account. If there are any questions, please call the undersigned at (949) 752-7040.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on August 21, 2002.


Sandy Kim

August 21, 2002

Respectfully submitted,


Theodore P. Lopez
Attorney for Applicant(s)
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